PER 14 MILES

6,762,450.



PTO/SB/21 (03-03) Approved for use through 04/30/2003. OMB 0651-0031 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE Inder the Paperwork Reduction Act of 1995, no person re required to respond to a collection of information unless it displays a valid OMB control number. Application Number 09/876,102 TRANSMITTAL Filing Date June 6, 2001 **FORM** First Named Inventor Gurtej Sandhu et al. Art Unit (to be used for all correspondence after initial filing) **Examiner Name** S. Crane Attorney Docket Number MI22-1736 Total Number of Pages in This Submission **ENCLOSURES** (Check all that apply) After Allowance Communication Fee Transmittal Form Drawing(s) to a Technology Center (TC) Appeal Communication to Board Licensing-related Papers Fee Attached of Appeals and Interferences Appeal Communication to TC Petition (Appeal Notice, Brief, Reply Brief) Amendment/Reply Petition to Convert to a Proprietary Information After Final Provisional-Application Power of Attorney, Revocation Status Letter Affidavits/declaration(s) Change of Correspondence Address Other Enclosure(s) (please Terminal Disclaimer Extension of Time Request Identify below): Return Receipt Postcard; Certificate of Request for Refund **Express Abandonment Request** Correction(2) CD. Number of CD(s) Information Disclosure Statement Remarks Certified Copy of Priority Document(s) Addtional Enclosure: Request for Certificate of Correction Certificate Response to Missing Parts/ Patent No.: 6,762,450 B2 JAN 2 1 2005 Incomplete Application Issued: July 13, 2004 Response to Missing Parts mplufing the form, cult 1-2001-PTU-U159 (1-800-738-9190) and sected a COLLECTION under 37 CFR 1.52 or 1.53 SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT Firm Jennifer J. Taylor, Ph.D., Reg. No. 48,711 Wells St. John, P.S. Individual Signature Date CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class*mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on this date: Typed or printed Natalie King Date Signature This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.s. 122 and 37 CFR 1.14. This collection is estimated to take 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, Washington, DC 20231. If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-786-9199) and select option 2. under 37 CFR 4,42 or 1,63 Roopense to Maning Potts Incemplate Apparentian lesued: July 13, 20th 1-200 31:00 00 101:00 03 Response to Moorg Pate/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No	6,762,450 B2
Patent Issue Date	July 13, 2004
	June 6, 2001
	Micron Technology, Inc.
	Sandhu et al.
	MI22-1736
Title: Method of Forming a Capacitor and A Capacitor Construction	

REQUEST FOR CERTIFICATE OF CORRECTION OF PATENT FOR PTO MISTAKE (37 C.F.R. 1.322(a))

To:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

ATTN:

Decision and Certificate of Correction

Branch of the Patent Issue Division

From:

Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

601 W. First Avenue, Suite 1300

Spokane, WA 99201-3828

Sir:

It is hereby requested that a Certificate of Correction be issued with respect to Patent No. 6,762,450 B2, granted July 13, 2004, in accordance with the Certificate of Correction form attached hereto in duplicate.

The errors listed on the Certificate of Correction form were apparently incurred through the fault of the PTO as will be disclosed by the records of files in the Office.

Since this Certificate of Correction is being requested due to PTO errors, it is believed that no fee is due. However, in the event that a fee is required for issuance of this Certificate of Correction, please charge the fee specified under

37 C.F.R. § 1.20(a) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Attached hereto, in duplicate is Form PTO-1050, with at least one copy being suitable for printing.

Respectfully submitted,

UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

PATENT NO.

: 6,762,450 B2

DATED

: July 13, 2004

INVENTOR(S)

: Gurtej Sandhu et al.

It is certified that errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title Page 1, "OTHER PUBLICATIONS", in the Institute of Semiconductor Physics reference, please delete "Temmter, D.," before "Multilayer Vertical" and insert -- Temmler, D.,--.

Title Page 1, "OTHER PUBLICATIONS", in the University of California reference, please delete "Nierdef, H.," before "Organometallic Chemical" and insert --Niemer, H.,--.

Title Page 2, "OTHER PUBLICATIONS", in the IEDM reference, please delete "H. Wannabe et al.," before "Stacked Capacitor" and insert --H. Watanabe et al.,--.

Col. 5, line 56, please delete "is" after "layer 34".

Page 1 of 1

Mailing Address of Sender:

Jennifer J. Taylor, Ph. D. Wells St. John P.S. 601 West First Avenue, Suite 1300 Spokane, WA 99201-3828 Patent No. 6,762,450 B2

UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF CORRECTION

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